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BIBDATASHEET**CONFIRMATION NO. 3899**

Bib Data Sheet

SERIAL NUMBER 10/694,053	FILING DATE 10/28/2003 RULE	CLASS 438	GROUP ART UNIT 2824	ATTORNEY DOCKET NO. 00684.003324.1.
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**** CONTINUING DATA *******

This application is a DIV of 10/068,988 02/11/2002 PAT 6,653,211

**** FOREIGN APPLICATIONS *******

JAPAN 033808/2001 02/09/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

**** 01/15/2004**

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 4	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

ADDRESS

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TITLE

Semiconductor substrate, SOI substrate and manufacturing method therefor

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
RECEIVED	No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> 1.16 Fees (Filing)
	No. _____ for following:	<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issues)

770	<div>1.18 Fees (Issue)</div> <div><input type="checkbox"/> Other</div> <div><input type="checkbox"/> Credit</div>
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